AMENDMENTS TO THE CLAIMS

Claims 1-9. (Canceled)

A substrate processing method, comprising: 10. (Withdrawn)

OK factor disposing anodes and cathodes, arranged alternately along at least one direction, so as to face a substrate held by a substrate holder;

supplying a processing liquid between said substrate, held by said substrate holder, and said anodes and cathodes; and

applying a voltage between said anodes and said cathodes.

The substrate processing method according to claim 10, further 11. (Withdrawn) comprising:

rotating said substrate while applying said voltage between said anodes and cathodes.

- The substrate processing method according to claim 10, wherein 12. (Withdrawn) supplying a processing liquid comprises supplying a processing liquid containing an electrolyte.
- The substrate processing method according to claim 10, further 13. (Withdrawn) comprising:

between said anodes and cathodes applying an electric current having at least one of an alternating current waveform, a direct current waveform, a direct current reverse voltage waveform, a pulse waveform, a PR pulse waveform, and a double pulse waveform.

14. (Withdrawn) The substrate processing method according to claim 10, wherein a distance between said substrate held by said substrate holder and said anodes differs from a distance between said substrate held by the substrate holder and said cathodes.